

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yoichiro Ohta	)
		)
Serial No.:	10/796,344	)
		)
Conf. No.:	1978	)
		)
Filed:	3/9/2004	)
		)
For:	VACUUM PROCESSING APPARATUS	)
		)
Art Unit:	1792	)
		)
Examiner:	Lund, Jeffrie Robert	)

AMENDMENT G

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 22, 2009, please amend the above-identified Application as follows.

Applicants petition the Commissioner of Patents and Trademarks to extend this time for response to the Office Action dated July 22, 2009 for one (1) month so that the period for response is extended to November 23, 2009.